



P-410

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of : *Sieck*
Naatz et al : Examiner: N/A
Serial No.: 09/928,459 : Group Art Unit 1743
Filed: August 14, 2001 : Att. Dkt.: ANA211
For: Wide-Range TOC Instrument Using Plasma Oxidation
JAN 28 2002

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TC 1700

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks
Washington, DC 20231

Dear Sir:

The most pertinent prior art practices and equipment known to applicants are discussed in detail in the specification of this application as filed, and reference is made thereto.

Submitted herewith are copies of two patents referred to in the application, a copy of a thesis also referred to in the text of the application, and two brochures describing the preferred power supply. These items are all listed on an accompanying PTO-1449. Also submitted herewith for completeness are copies of the results of several keyword searches performed on the NERAC database, which may be of interest to the Examiner.

Early and favorable action on the merits is respectfully requested.

Respectfully submitted,

Dec. 20, 2001
Dated

[Signature]
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INFORMATION DISCLOSURE CITATION IN AN APPLICATION				EXAMINER NUMBER ANA211	APPLICATION NUMBER 09/928,459 JAN 28 2002			
				APPLICANT Naatz et al	FILING DATE 8/14/01			
				GROUP ART UNIT N/A				
TG 1700								
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL	DOCUMENT NUMBER		DATE	NAME		CLASS	SUBCLASS	FILING DATE
	4 6 2 6 4 1 3	12/1986	Blades					
	6 1 1 4 7 0 0	09/2000	Blades					
FOREIGN PATENT DOCUMENTS								
	DOCUMENT NUMBER		DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)								
	Bondarowicz, "Total organic carbon analysis by inductively coupled plasma spectroscopy", MS thesis, Roosevelt University (1992)							
	Haiden Laboratory Co., Ltd., "Plasma generating power source", undated brochure							
	Haiden Laboratory Co., Ltd., "Bipolar high-frequency pulse power source", undated brochure							
EXAMINER	DATE CONSIDERED							
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 804; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.								